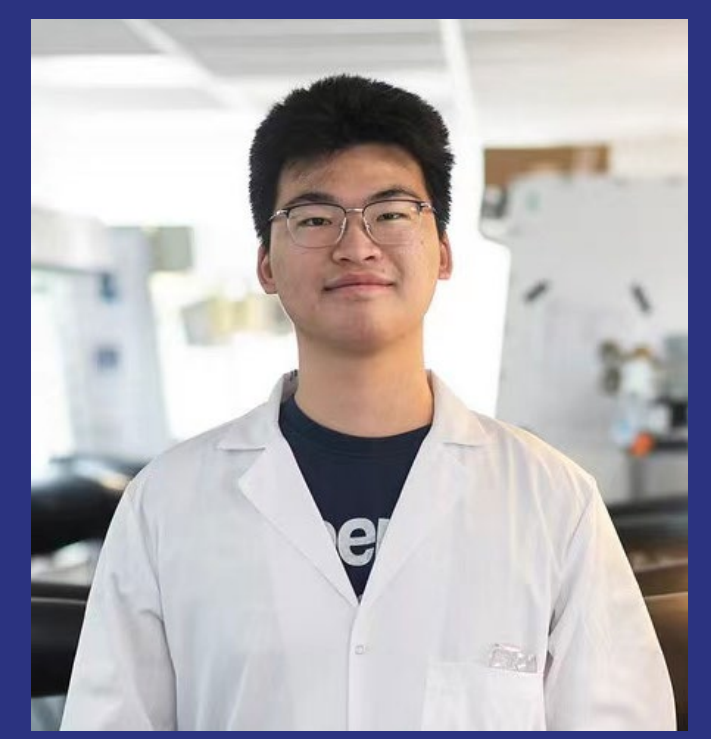


Study of the Interfacial Stability of Thin-film LiPON Electrolytes

Attempts to measure the critical current density accurately and reveal the SEI evolution of LiPON|Li

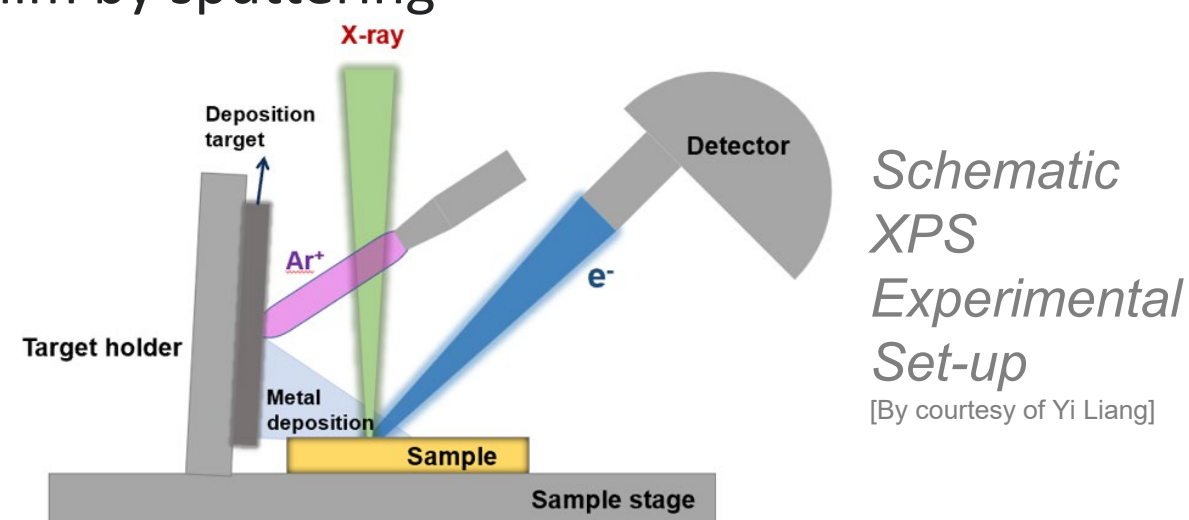


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Abstract

Our work aims to provide key information for understanding the remarkable performance of dendrite suppression:

i. XPS analysis of in-situ Li deposition on LiPON film by sputtering

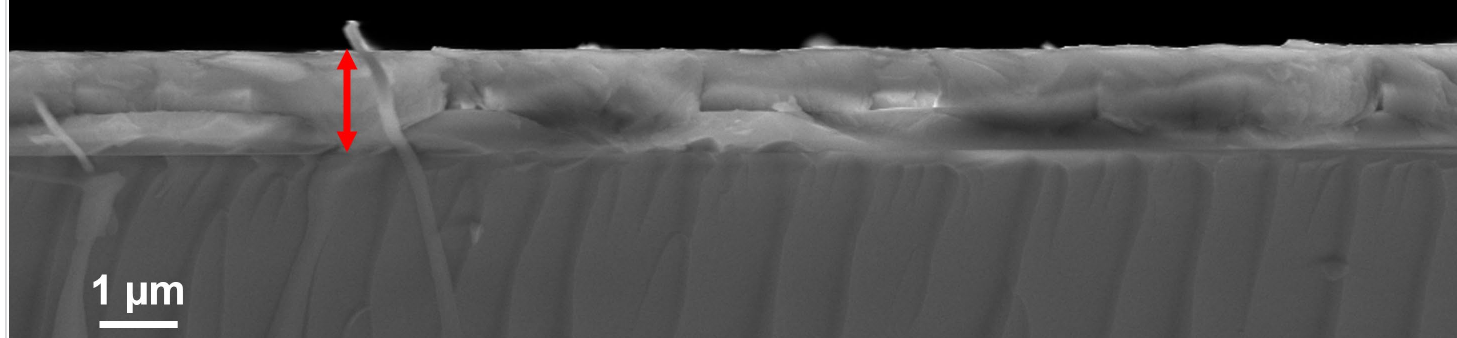


ii. Cell configurations have been iterated in attempts to confirm a precise value of critical current density, indicative of interfacial stability

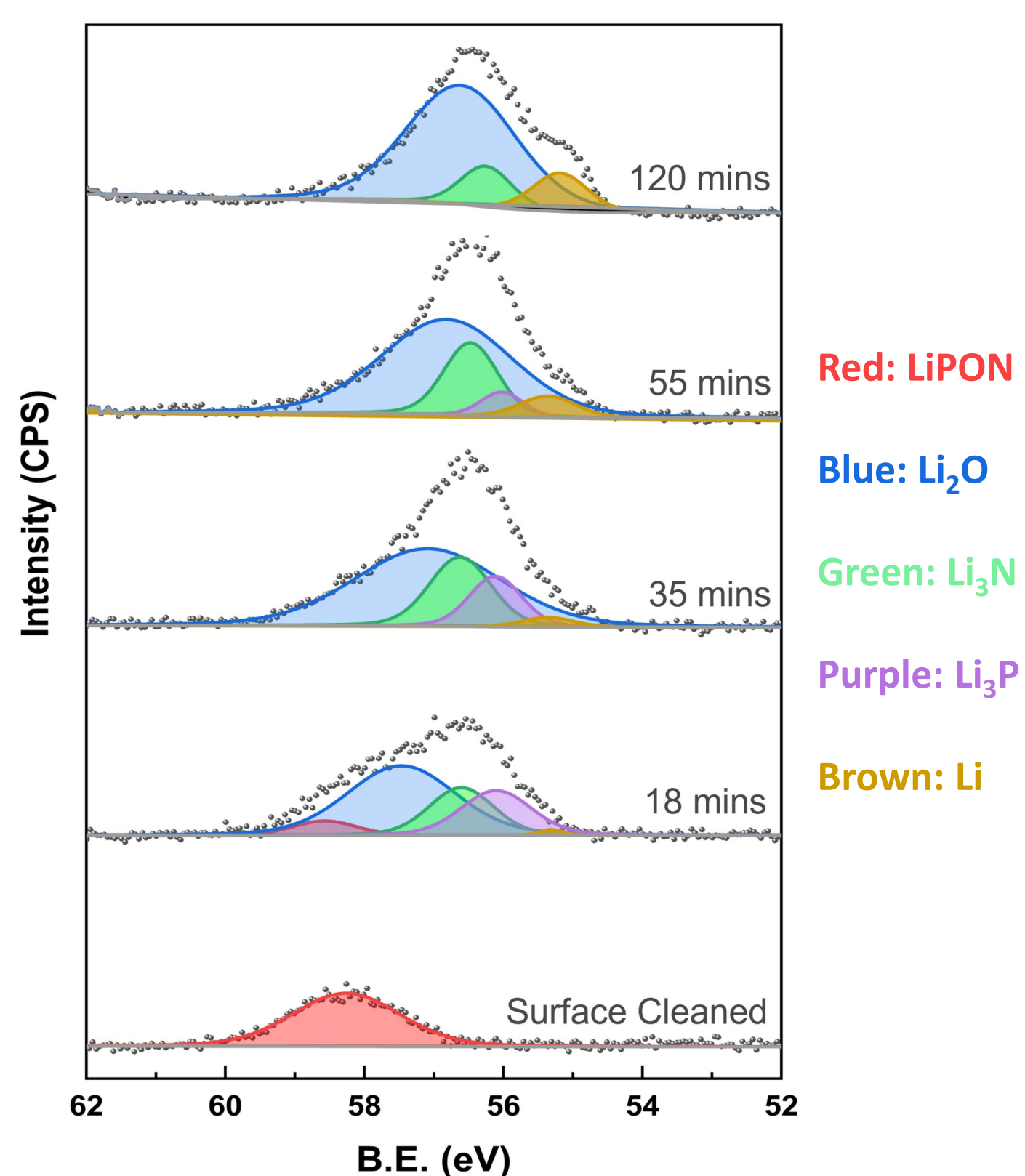
- The main challenge is to sputter an intact LiPON thin film homogeneously upon the bottom electrode

Cross-sectional SEM Image of LiPON film

1.3 μm homogeneous and pore-free LiPON thin film deposited on a silicon substrate



XPS Peak Fitting



- The XPS signal shows 100% LiPON after the surface is cleaned and without Li sputtered
- Five component peaks evolve as lithium is sputtered in situ for a longer time

Impact / Next Steps

- In this work, SEI evolution is suggested, and its stacking layer structure is confirmed by in situ XPS analysis of lithium sputtering on LiPON
 - Considering close binding energies of Li_2O , Li_3N , and Li_3P , peak fitting can be more accurate if the binding energy of each is determined in our equipment beforehand.
 - To confirm trends obtained by the in situ XPS technique, instead of sputtering lithium on LiPON, lithium is produced by Li/Li^+ charging.
- For $\text{Li}|\text{LiPON}|\text{Li}$ cells, it is hopeful that successful CCD measurements can be made when the Li layer below the LiPON is less than 50 nm
 - Replace the bottom Li layer with harder and stiffer LCO at a thickness with sufficient lithium.

Motivation

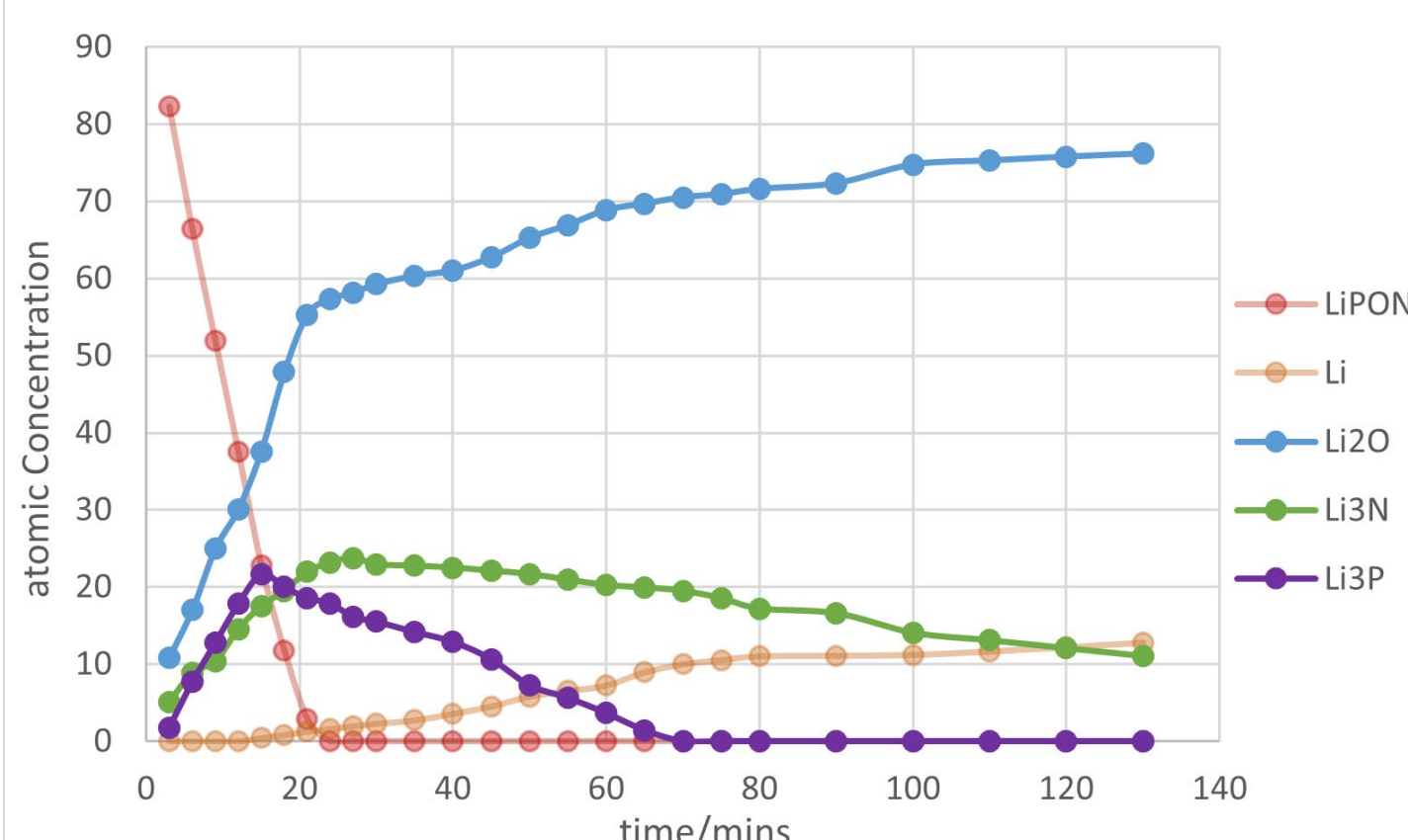
- Li metal anodes, expected to boost energy density by 30% more than graphite-based ones, are practically difficult to incorporate due to the Li dendrite penetration which leads to cell shorting over repeated cycling. **RF magnetron sputtered LiPON can completely suppress Li dendrites.** One impressive example is to visualize dendrite propagation as completely constrained in a 2D plane between two transparent LiPON layers. [1]



Source: <http://pubs.acs.org/journal/aecpp>

Qualitative Analysis of XPS Results

Lithium Component Evolution



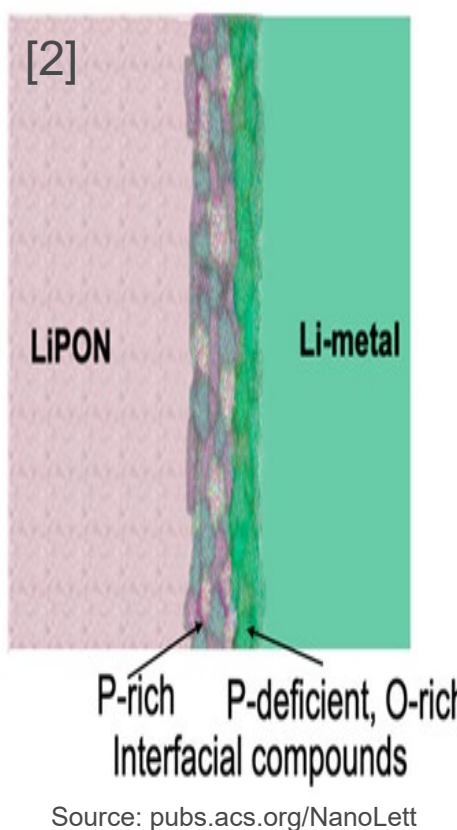
Main Features:

- Atomic concentration of LiPON in lithium decreases monotonically and quickly drops to zero after 21-minute lithium sputtering.
- Li starts to be detected after 15 minutes, indicating roughly the time at which the SEI is established stably.
- Li_2O increases in atomic content quickly before LiPON has not reached zero but at a lower rate afterward as there is only unreacted Li oxidised in not perfectly vacuum environment.
- Li_3N concentration peaks at 27 minutes
- Li_3P concentration peaks at 15 minutes and reaches zero after 70-minute lithium sputtering

Possible SEI Configuration

Reason for peaking of Li_3N and Li_3P :

- There is an atomic concentration gradient due to the diffusion and thus as thicker Li sputtered and the X-ray detection range is lifted; therefore, nitrate and phosphate trendlines increase firstly;
- Time, at which peaks are reached, indicates the interfaces between two adjacent layers;
- Atomic concentrations decrease as more side products get outside the detection range than those produced in reactions with Li.



These XPS trends match well with **stacking-layer SEI configuration**

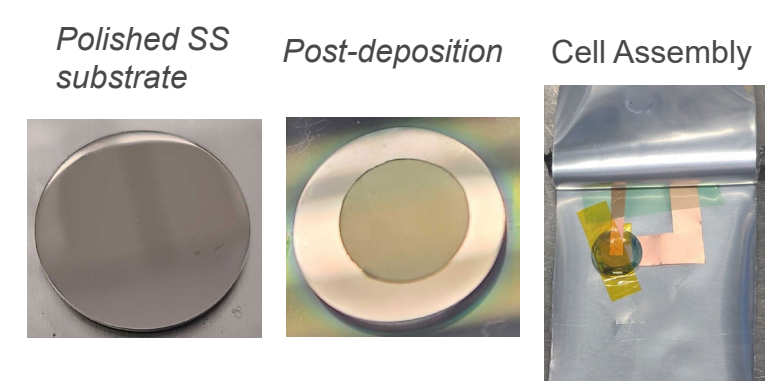
References

- Westover, A.S., Dudney, N.J., Sacchi, R.L. and Kalnaus, S., 2019. Deposition and confinement of Li metal along an artificial LiPON-LiPON interface. *ACS Energy Letters*, 4(3).
- Hood, Zachary D., et al. "Elucidating interfacial stability between lithium metal anode and Li phosphorus oxynitride via in situ electron microscopy." *Nano Letters* 21.1 (2020).

Methods



Stainless Steel (SS) Substrate Deposition for CCD Measurements:



Substrates stuck to the rotating disc upside down with Kapton tape

Li_3PO_4 Sputtering Target The sputtering rate is detected with a probe above.

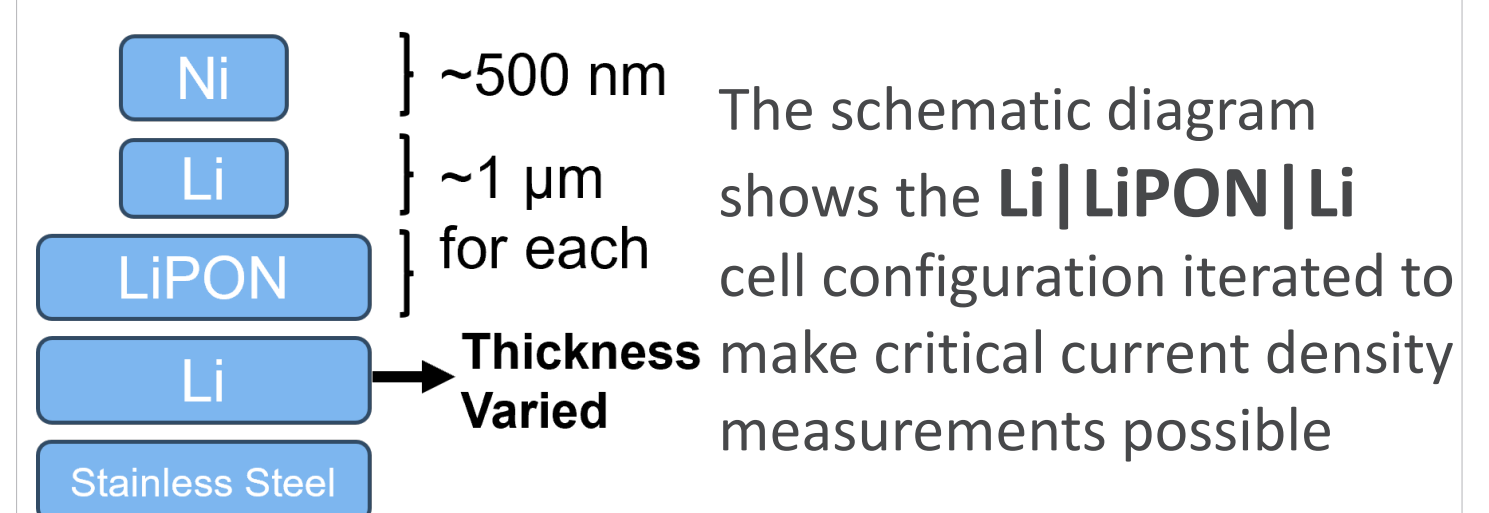
The red glow is seen during the magnetron sputtering discharge for LiPON.

The nickel layer is also sputtered with a nickel target.

Evaporation set-up requires lithium granules held in a lithium melting boat. The evaporation rate is monitored by quartz oscillation frequency.

The evaporation rate is $\sim 2 \text{ \AA/s}$.

Cell Configuration Development for CCD Measurements

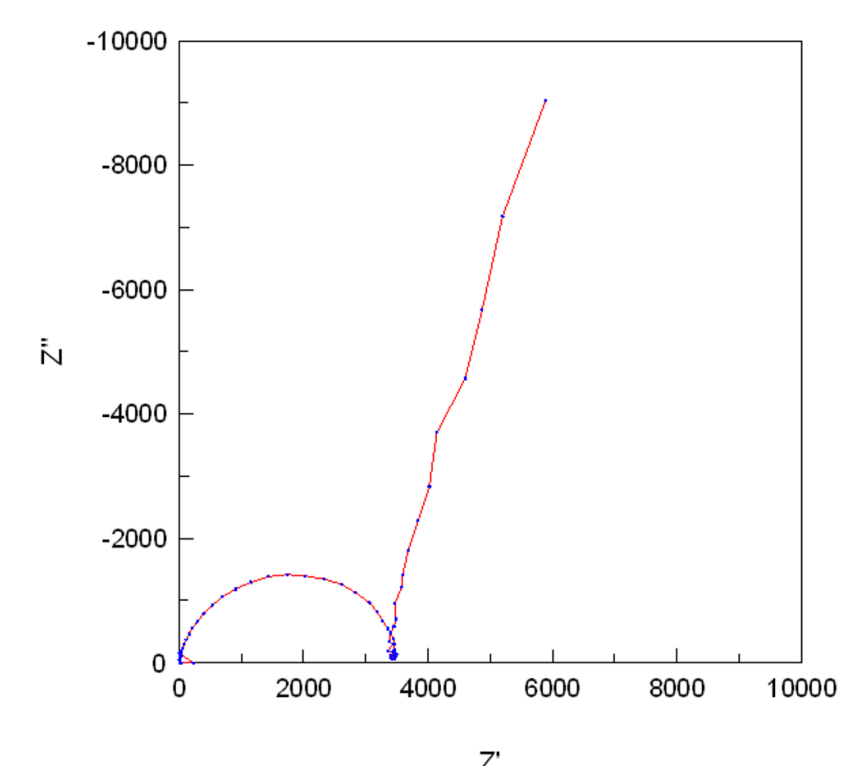


Trial 1: Lower Li layer thickness = 0 μm

EIS:

The conductivity is $4 \times 10^{-6} \text{ S/cm}$

- This configuration gives a reference of LiPON conductivity



Trial 2&3: Lower Li layer thickness = 6 μm & 1 μm

EIS:

Measurement failures due to short-circuit:

- Sputtered LiPON molecules bombard the soft lithium bed and deform the thick lithium layer plastically to form protrusions.
- Therefore, the unevenness of the thin LiPON film on soft lithium results in contact between the two Li electrodes.

Trial 4: Lower Li layer thickness = 0.05 μm

EIS:

The impedance due to inductance is detected:

- The protrusions are smaller relative to the LiPON film thickness
- Reduction in Lithium layer thickness to nanometre region is promising for allowing critical current density measurements.

Intern bio

Tiancheng is a second-year undergraduate studying Materials Science at the University of Oxford, aspiring to pursue a Ph.D. degree in Materials Science. He completed his first official summer research internship in Professor Mauro Pasta's group at the University of Oxford.

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